

10/517656

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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q84298

Hitoshi KIDOKORO, et al.

Appln. No.: National Stage of PCT/JP03/07574

Confirmation No.: Unknown

Group Art Unit: Unknown

Filed: December 13, 2004

Examiner: Unknown

For: LASER MACHINING APPARATUS AND CONTROL METHOD FOR THE APPARATUS

PRELIMINARY AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Prior to examination, please amend the above-identified application as follows on the accompanying pages.

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